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PATENT Atty. Dkt. No. SOEI/0037

2866

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ito, et al.

Serial No.: 09/830,631

Confirmation No.:

Filed:

April 30, 2001

For:

Ion Implantation Apparatus

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Group Art Unit: 2878

Examiner:

Unknown

JUN-6 2002

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited on 22 / 2002 with the United States Postal Service as First Olass Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C., 20231.

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Signature

REVOCATION AND POWER OF ATTORNEY

The Assignee of the above captioned application, Applied Materials, Inc., hereby revokes the previously appointed power of attorney for this application.

Assignee hereby appoints the following attorneys/agents to prosecute this application and transact all business in the Patent & Trademark Office connected therewith:

Raymond R. Moser, Jr. B. Todd Patterson Keith M. Tackett William B. Patterson Registration. No. 34,682 Registration No. 37,906 Registration No. 32,008 Registration No. 34,102

Send correspondence and telephone calls to:

William B. Patterson MOSER, PATTERSON & SHERIDAN, LLP 3040 Post Oak Blvd., Suite 1500 Houston, TX 77056

Telephone: (713) 623-4844

Fax (713) 623-4846

and grant full powers to prosecute this application, to make alterations and amendments therein, to inspect and make copies thereof and of any papers in appellate and inter party proceedings in which it may be involved, and to transact all business in the United States Patent & Trademark Office connected therewith.

Respectfully submitted,

Joseph J. Sweeney

Group Vice President and Secretary

Applied Materials, Inc. 3050 Bowers Avenue Santa Clara, CA 95054

Date : May 1, 2002